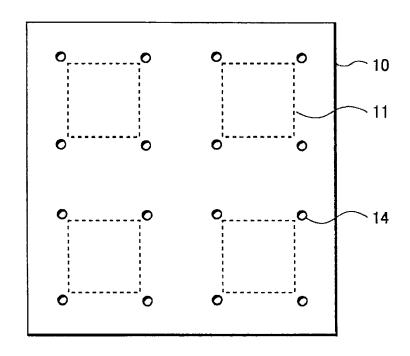
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FIG.1A



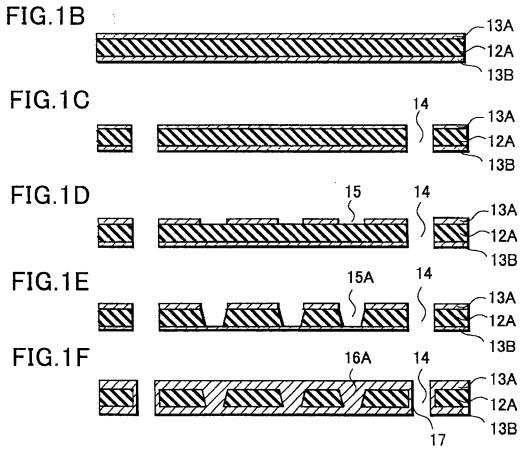
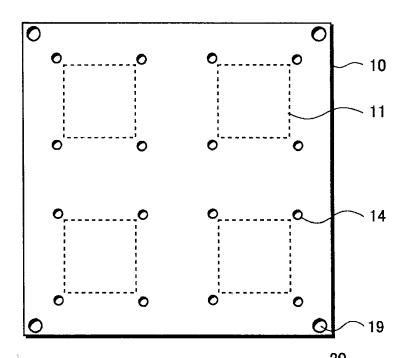
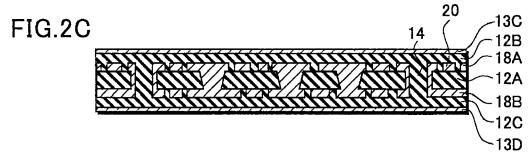
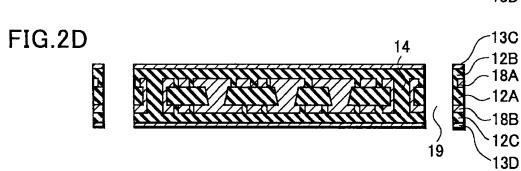


FIG.2A









12A 18B 12C

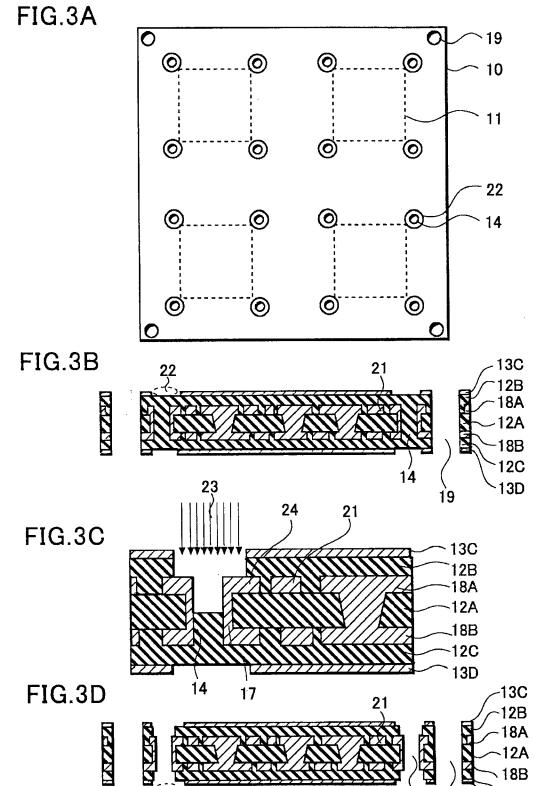
13D

19

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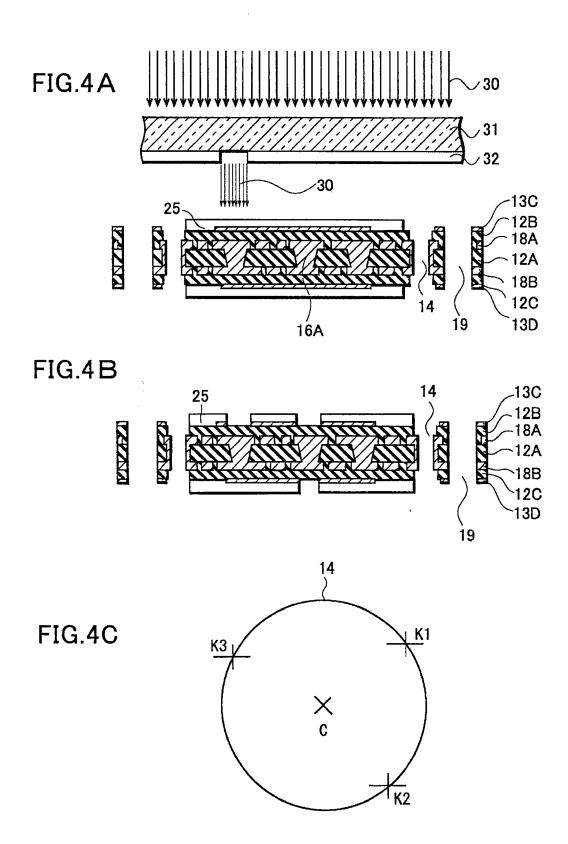


5

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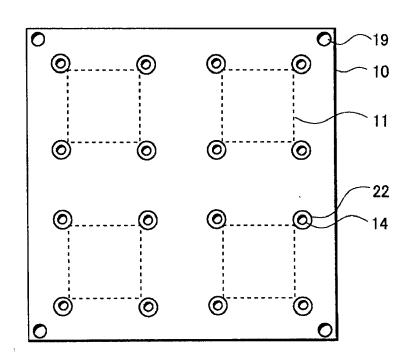
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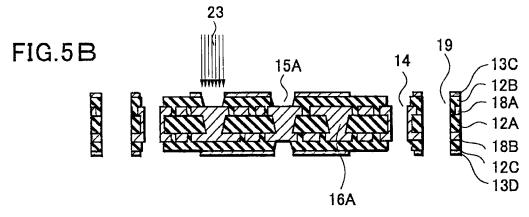
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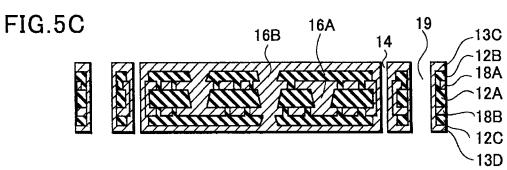


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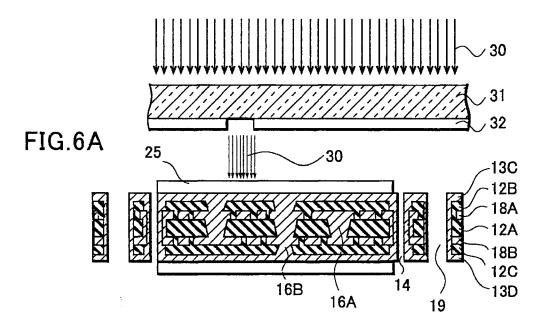






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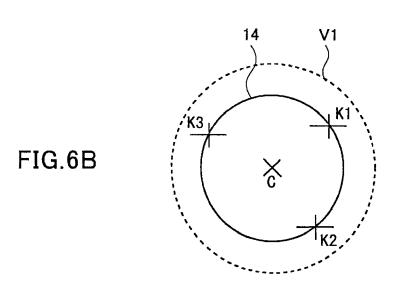


FIG.7A

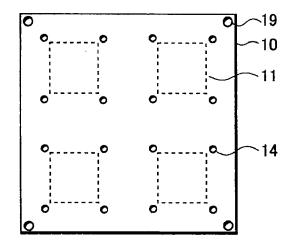


FIG.7B

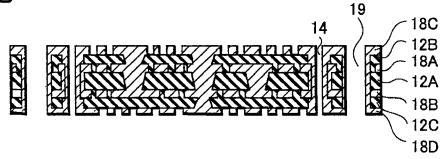
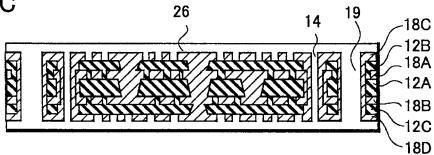
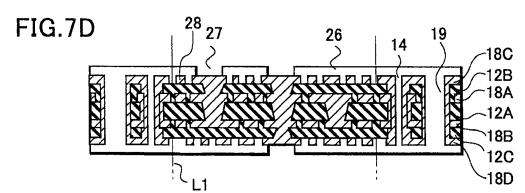


FIG.7C





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FIG.8A

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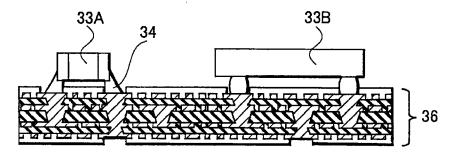
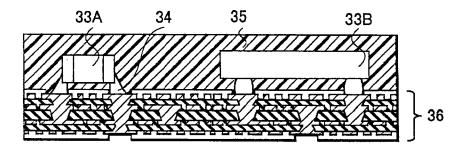


FIG.8B



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FIG.9A

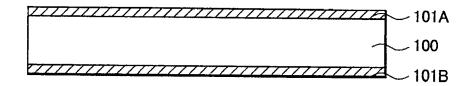


FIG.9B

